

2017 Editorial Calendar

(Editorial close date: 4/21)	July • August	* indicates show distribution
OSATs: Challenges for revenue growth High-density advanced packaging solutions f	for today's OSATs & foundries	• ICEPT 2017 Harbin, China (Aug 16-19) • BiTS China 2017
Wafer thinning		Shanghai, China (Sept 7) • SEMICON Taiwan *
TSV technologies for next-gen application challenges		Taipei, Taiwan (Sept 13-15) • SMTA International *
Die attach solutions		Rosemont, IL (Sept 17-21) • European MEMS & Sensors Summit
Performance and cost for 2.5D packaging	Grenoble, France (Sept 20-22)	
3D metrology challenges		
3D capacitors for on-chip integration		
HVM of chip-on-submount		

Ad Space Close Jun 30 - Ad Materials Close Jul 7

(Editorial close date: 6/9)	September • October	* indicates show distribution	
Technology trends in photonics packaging		• IMAPS 2017 * Raleigh, NC (Oct 9-12)	
Lithographic challenges for PLP		IWLPC-International Wafer-Level Packaging Conference & Exhibition *	
Packaging ICs/sensors for automotive applications		San Jose, CA (Oct 24-26) • International Test Conference (ITC)	
High-volume via formation in solid-core glass for IC substrates		Fort Worth, TX (Oct 31- Nov 2) • MEMS & Sensors Executive Congress	
Excimer laser ablation for fine RDL routings		Napa Valley, CA (Nov 1-2) • SEMICON Europa Munich, Germany (Nov 14-17)	
Final test	ividition, Commany (NOV 14 17)		
Packaging SiPs/SiP supply chain			
Interferometry sensors for metrology applications			
Non-destructive 3D X-ray imaging for advanced pack			

Ad Space Close Sep 9 - Ad Materials Close Sep 16

(Editorial close date: 9/1)	November • December	* indicates show distribution	
2.5D & 3D ICs		• 3D ASIP Conference * Burlingame, CA (Dec 5-7) • EPTC 2017 Singapore (Dec 6-9) • SEMICON Japan Tokyo, Japan (Dec 13-15)	
Probe technology for advanced 3D chips			
China IC market update			
Packaging challenges for automotive applications		SEMI European 3D Summit * Grenoble, France (Jan 22-24, 2018)	
Optimization of fan-out die placement			
What's now & next in MEMS & Sensors			
TCB – Part 2			
IC cleaning process			
Flip-chip assembly reliability			

International directory of bonding equipment for 2.5D & 3D assembly

Ad Space Close Nov 4 - Materials Close Nov 11